



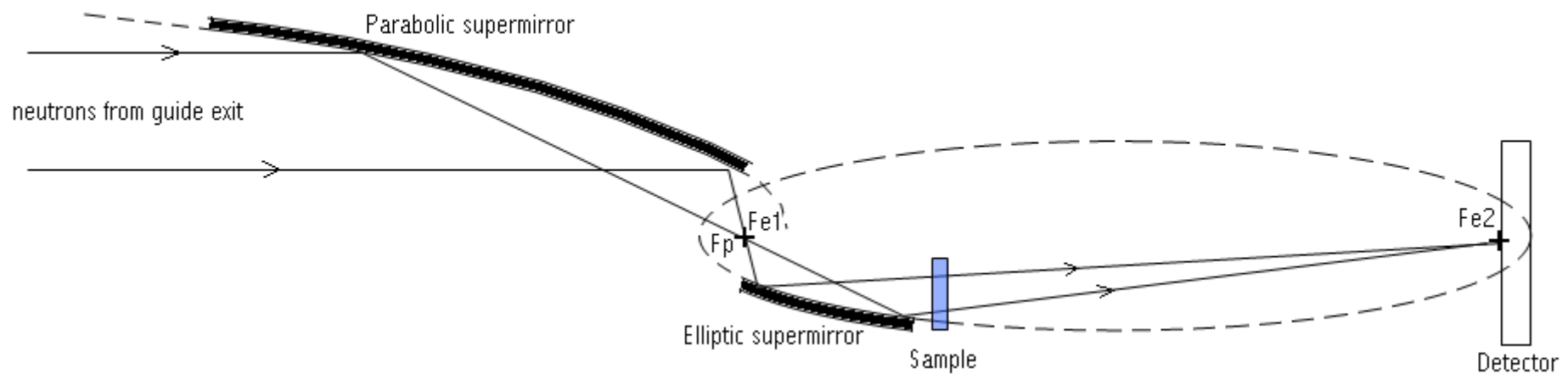
FOCUSSING SANS

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JRA presentation
General Assembly
Rome 2011, Nov. 8th

Task 4: Focussing SANS using reflective optics

- Intensity enhancement:
 - use of the whole guide surface
 - increased usefull divergencence
- No wavelength dependance : focussing by reflection
- Design flexibility

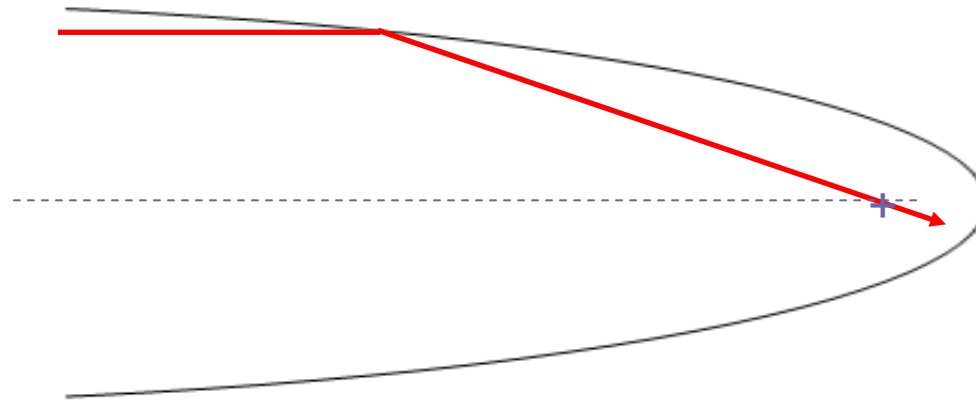




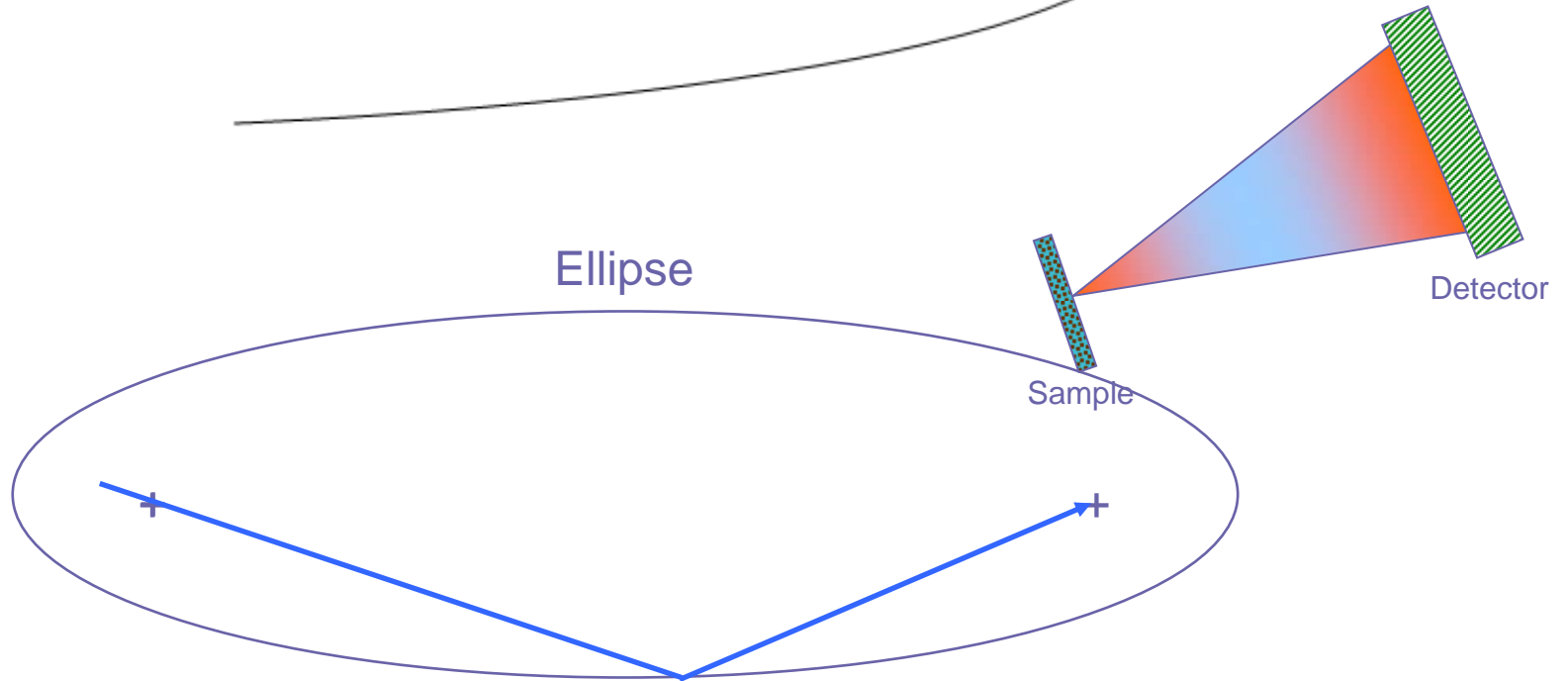
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Principle

Parabola



Ellipse





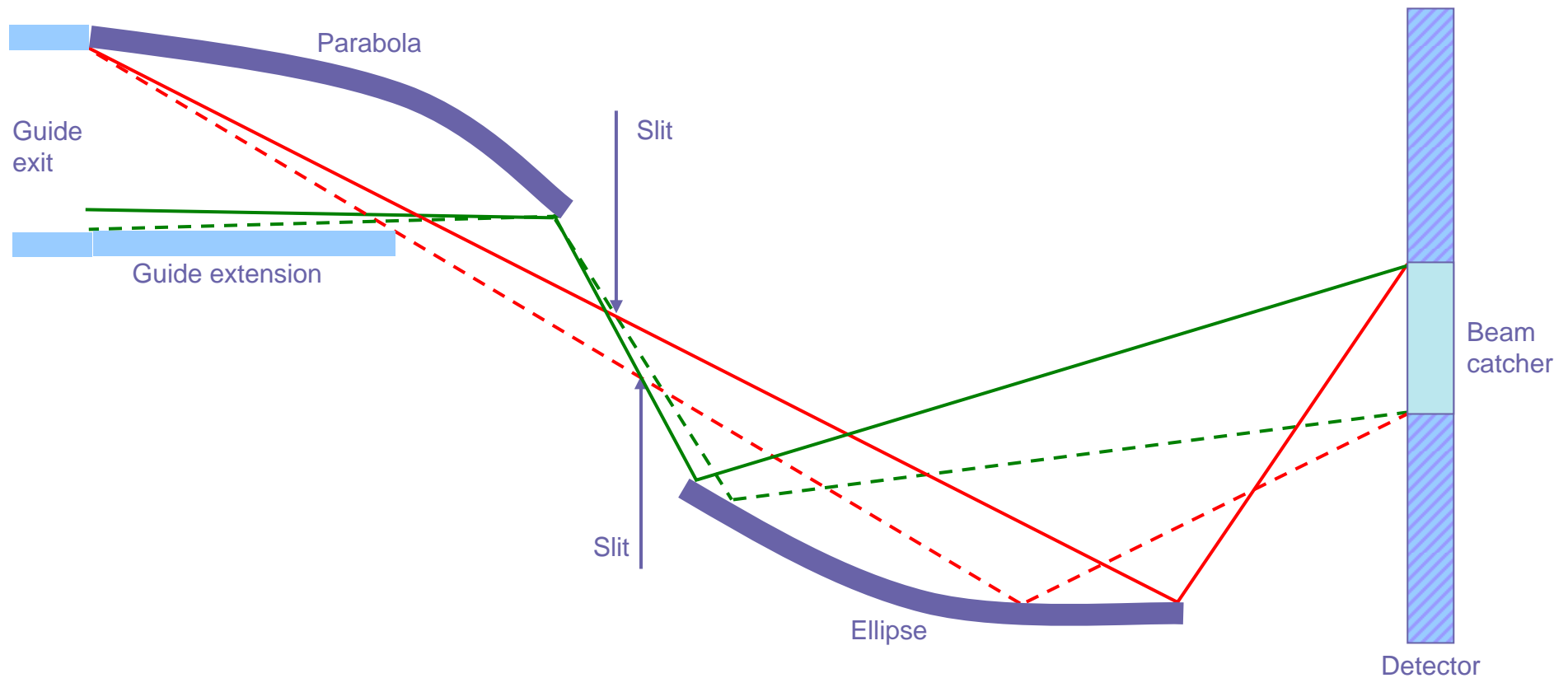
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Parameters

- Overall spectrometer length
- Dimension of guide exit
- Minimum λ to handle
 - determines critical angle of the parabolic SM
 - high $\lambda \rightarrow$ compact spectrometer
- m of the SM
 - determines critical angle
 - reflection coefficient
- Qmin

Collimation

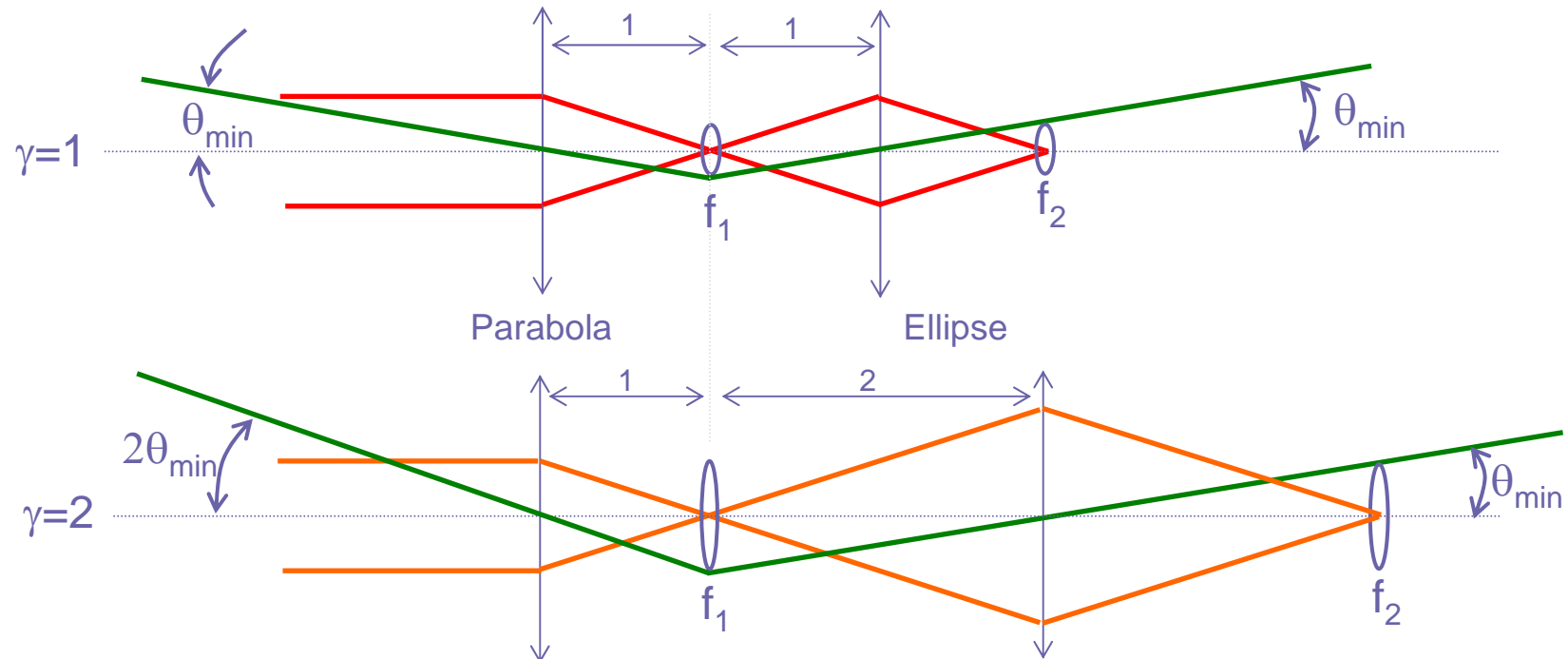
- Collimation made by slits located at the common focal point:



- Slit dimension determines the beam spot size $\rightarrow \theta_{\min} \rightarrow Q_{\min}$

Design parameters

- Gain factor (γ) : ratio of elliptic and parabolic focal lengths



- When γ increases, the usefull divergence at the guide exit increases:



Intensity increases



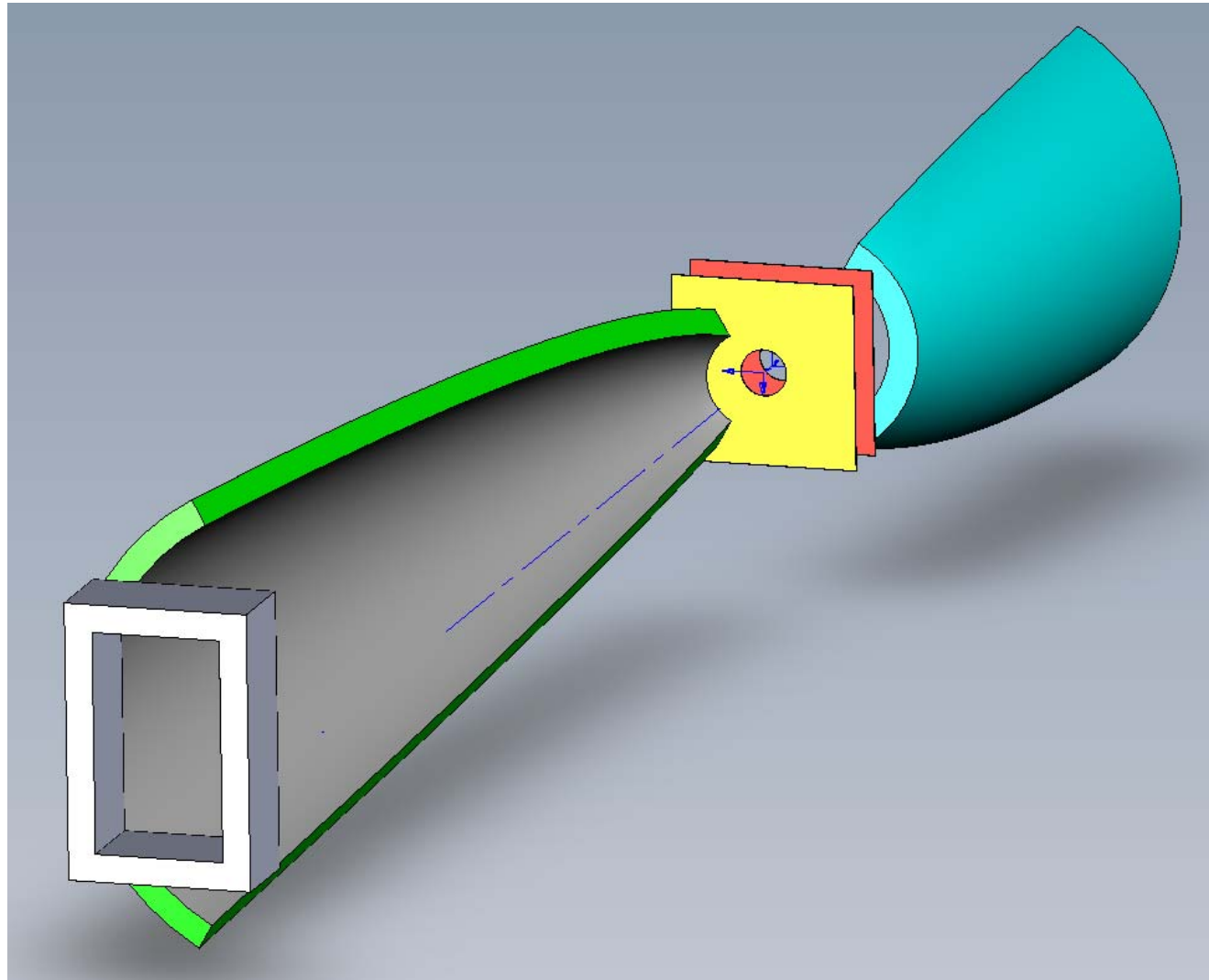
Sample size increases

→ Flux = Constant



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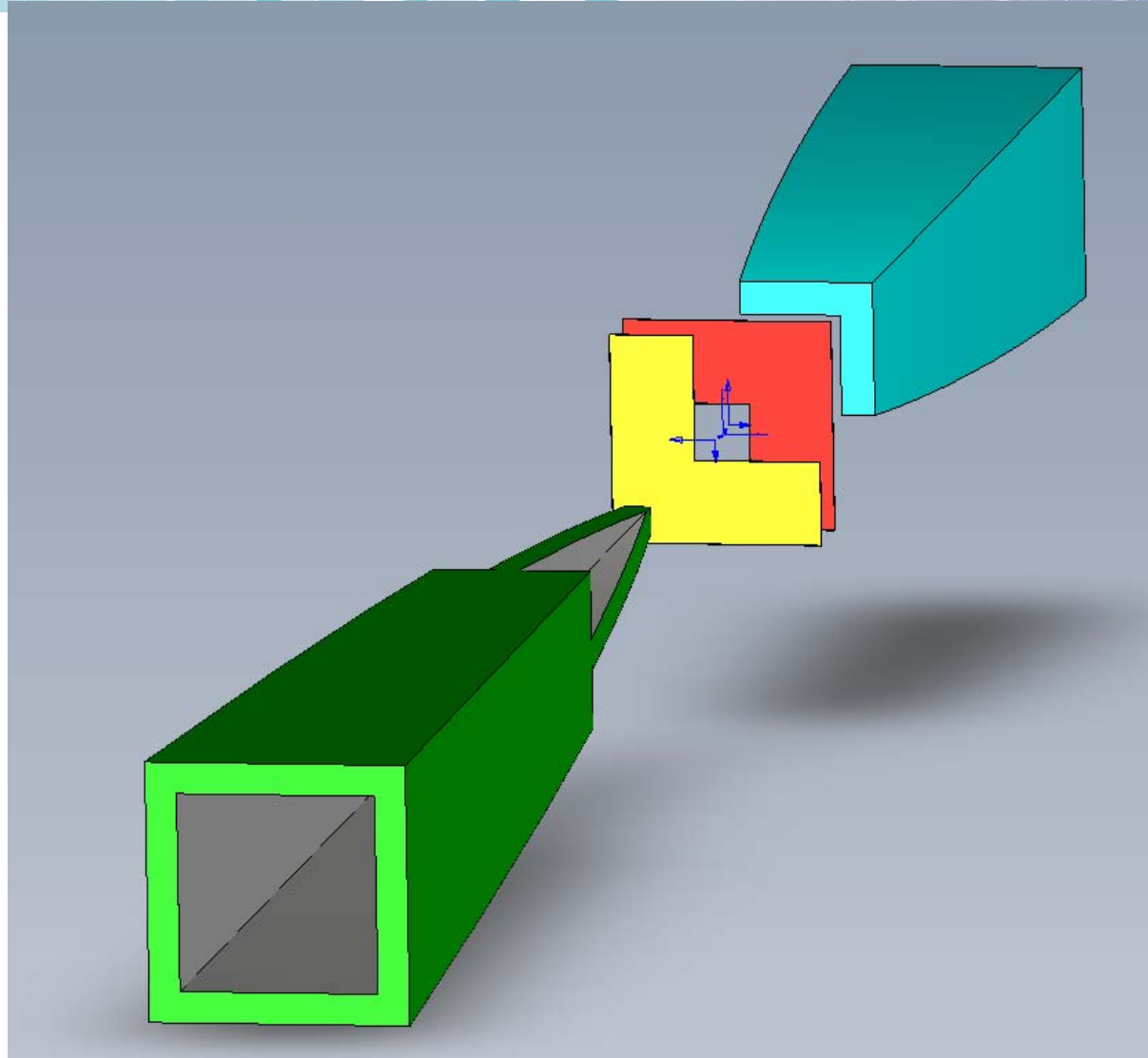
3D View (2 reflections)





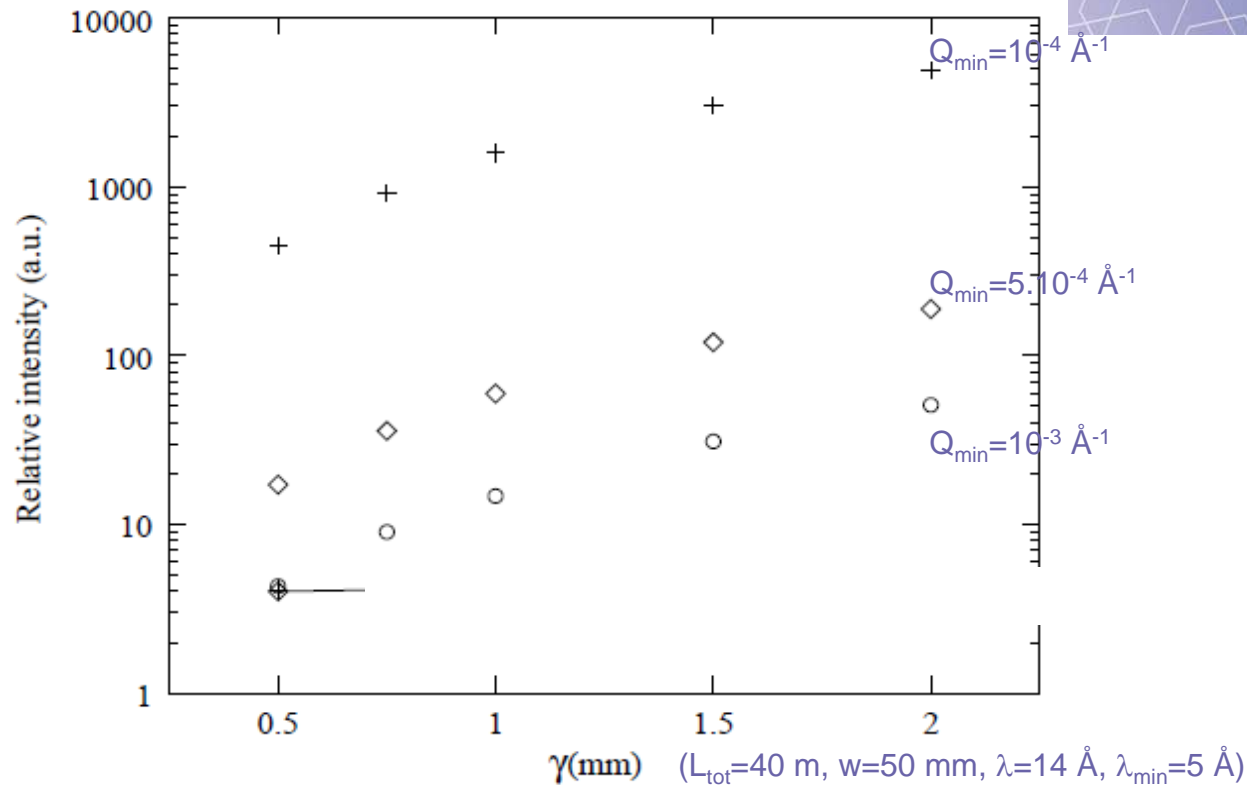
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3D View (4 reflections)





Comparison with pinhole SANS



- Gain (towards pinhole SANS) increases when Q_{min} decreases (gain $\sim Q_{\text{min}}^{-2}$)
- Gain much larger than multibeam technique
- Flux gain = constant (4 here) in case the sample size is imposed



Achromatic



- Flexible design to optimize constraints
(guide exit, overall length, ...)



- Large intensity gain
(reflection efficiency 90% @ $m=3$)
2 reflections, $T=80\%$
4 reflections, $T=65\%$



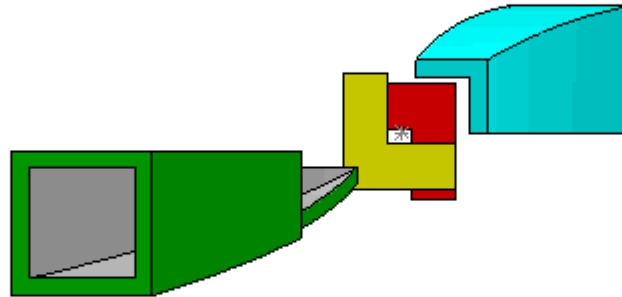
- Increased background - diffuse scattering from SM
To be studied



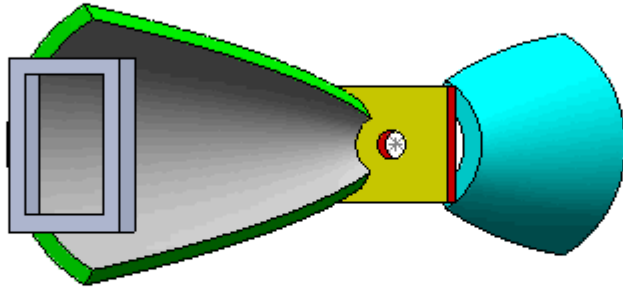
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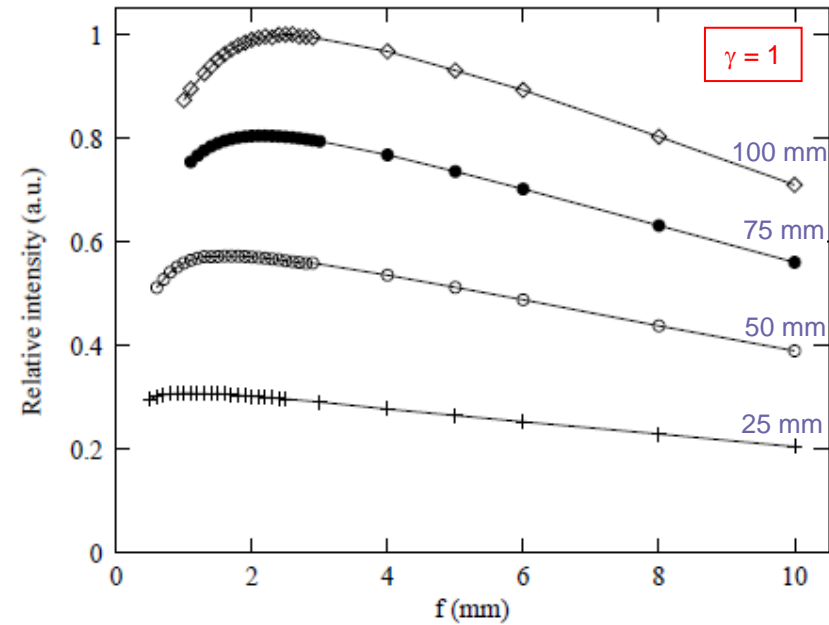
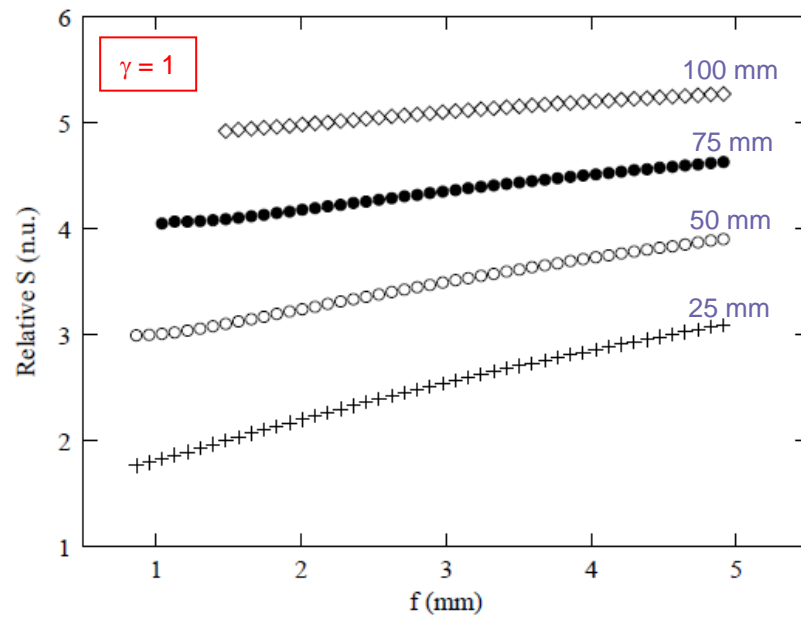
1st year project

- Find parameters
 - λ_{\min} , largest γ , f , spatial filters
- Follow SM quality for noise reduction
 - Manufacturers
 - McStas ?
- Build a reduced scale prototype
 - along 1D
 - 4 reflections principle
- Test prototype
 - Signal/Noise ratio



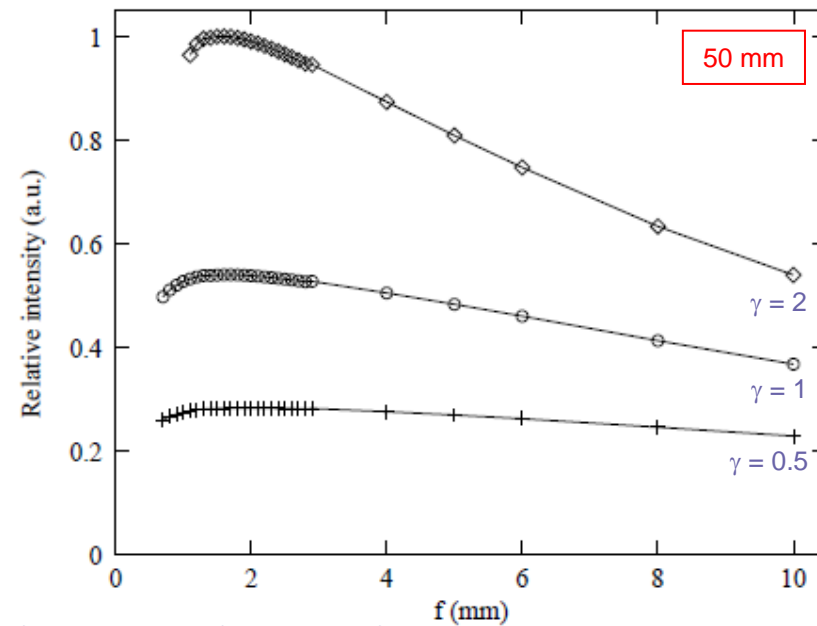
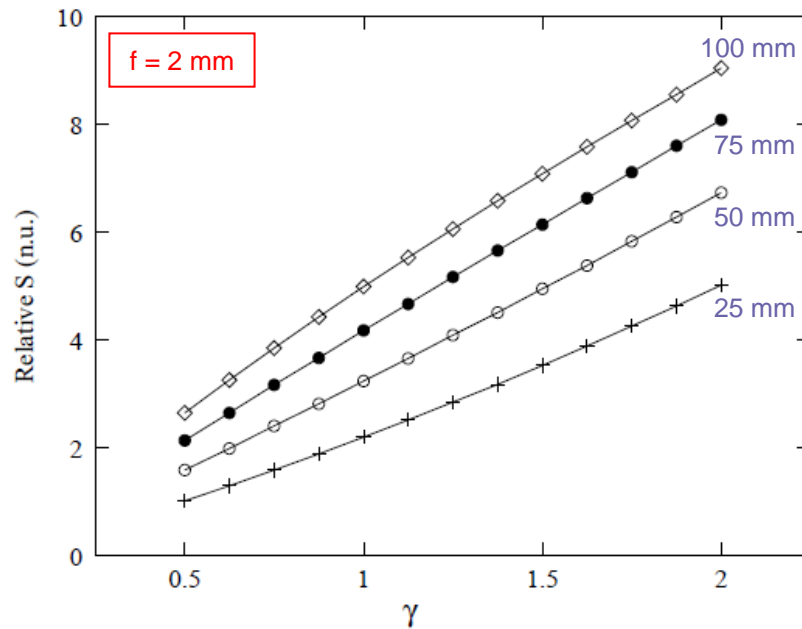
 **nmi3** 3D View (2 reflections)





($L_{\text{tot}}=40$ m, $Q_{\text{min}} = 10^{-3} \text{ \AA}^{-1}$ @ $\lambda=14 \text{ \AA}$, $\lambda_{\text{min}}=5 \text{ \AA}$)

- Sample size increases with the focal length (and guide dimension)
- There is an optimum focal length for the intensity



($L_{\text{tot}}=40$ m, $Q_{\text{min}} = 10^{-3} \text{ \AA}^{-1}$ @ $\lambda=14 \text{ \AA}$, $\lambda_{\text{min}}=5 \text{ \AA}$)

- Sample size increases \sim linearly with γ
- Intensity (around f_{opt}) increases \sim linearly with γ

→ Flux is constant

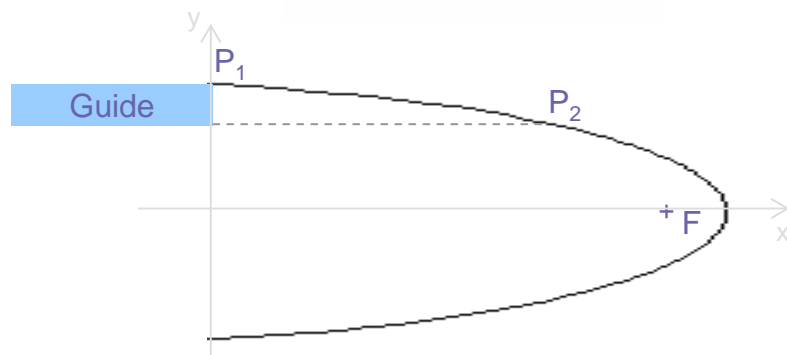
Parabolic SM

$$\tan 2\theta_0 = \frac{y_{P2}}{x_{P2} - x_F}$$

$$y_{P2}^2 = 4f(x_F + f - x_{P2})$$

$$x_F = \frac{(y_{P1}^2 - 4f^2)}{4f}$$

$$y_{P1}^2 = (y_{P2} + w)^2$$

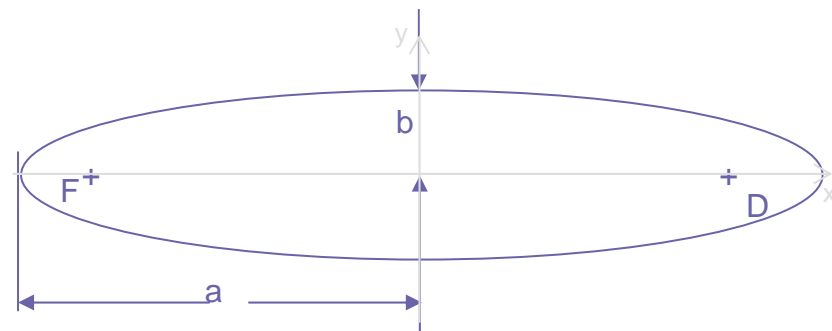


Elliptic SM

$$x_D - x_F = (a^2 - b^2)^{\frac{1}{2}}$$

$$\frac{(x - a)^2}{a^2} + \frac{y^2}{b^2} - 1 = 0$$

$$a = \frac{x_D - x_F}{2} + \gamma f$$

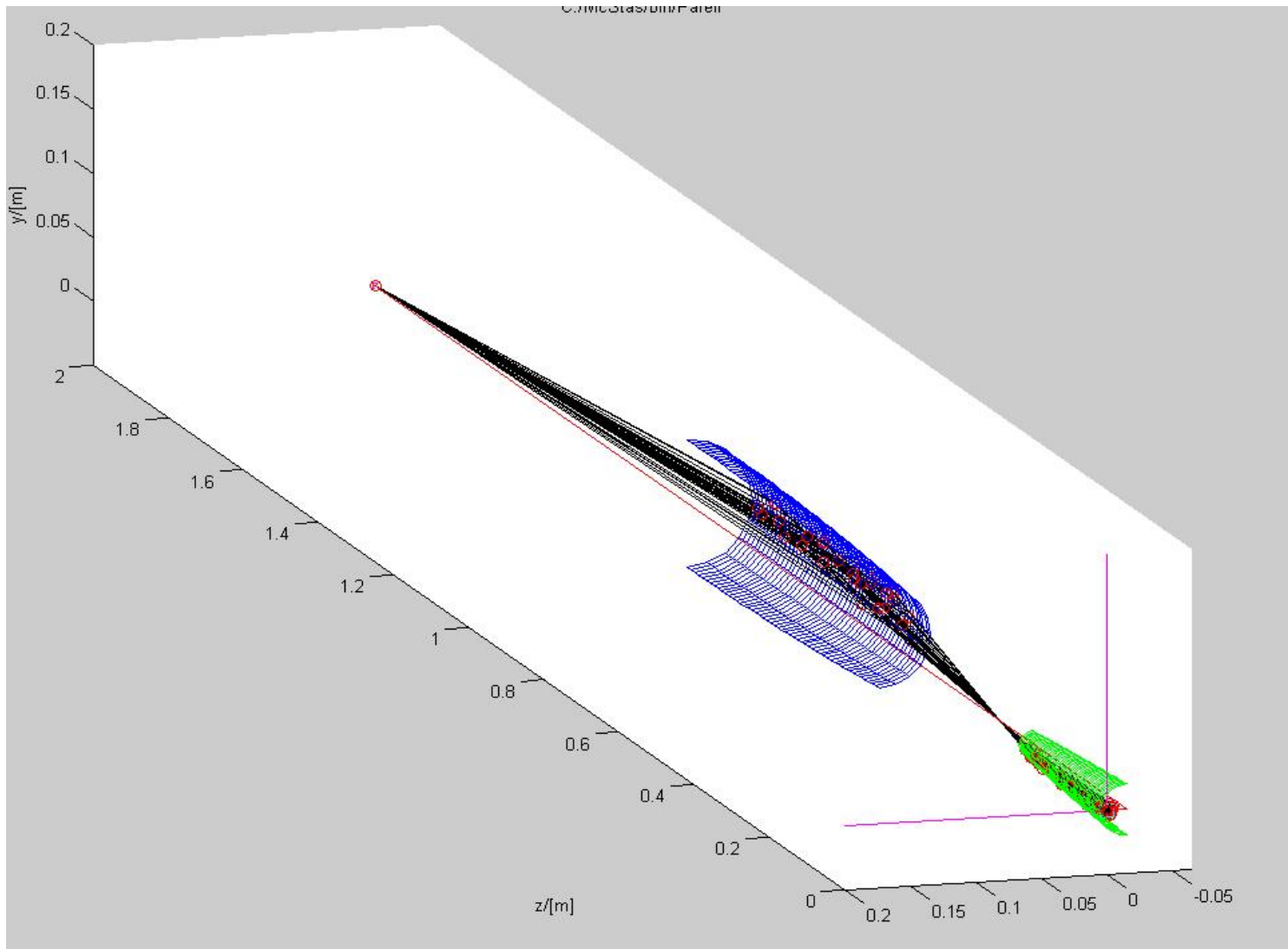




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SANS focusing with reflective optics

S. Désert





1D prototype





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1D prototype specifications:

Total instrument length

2 m

Parabolic mirror

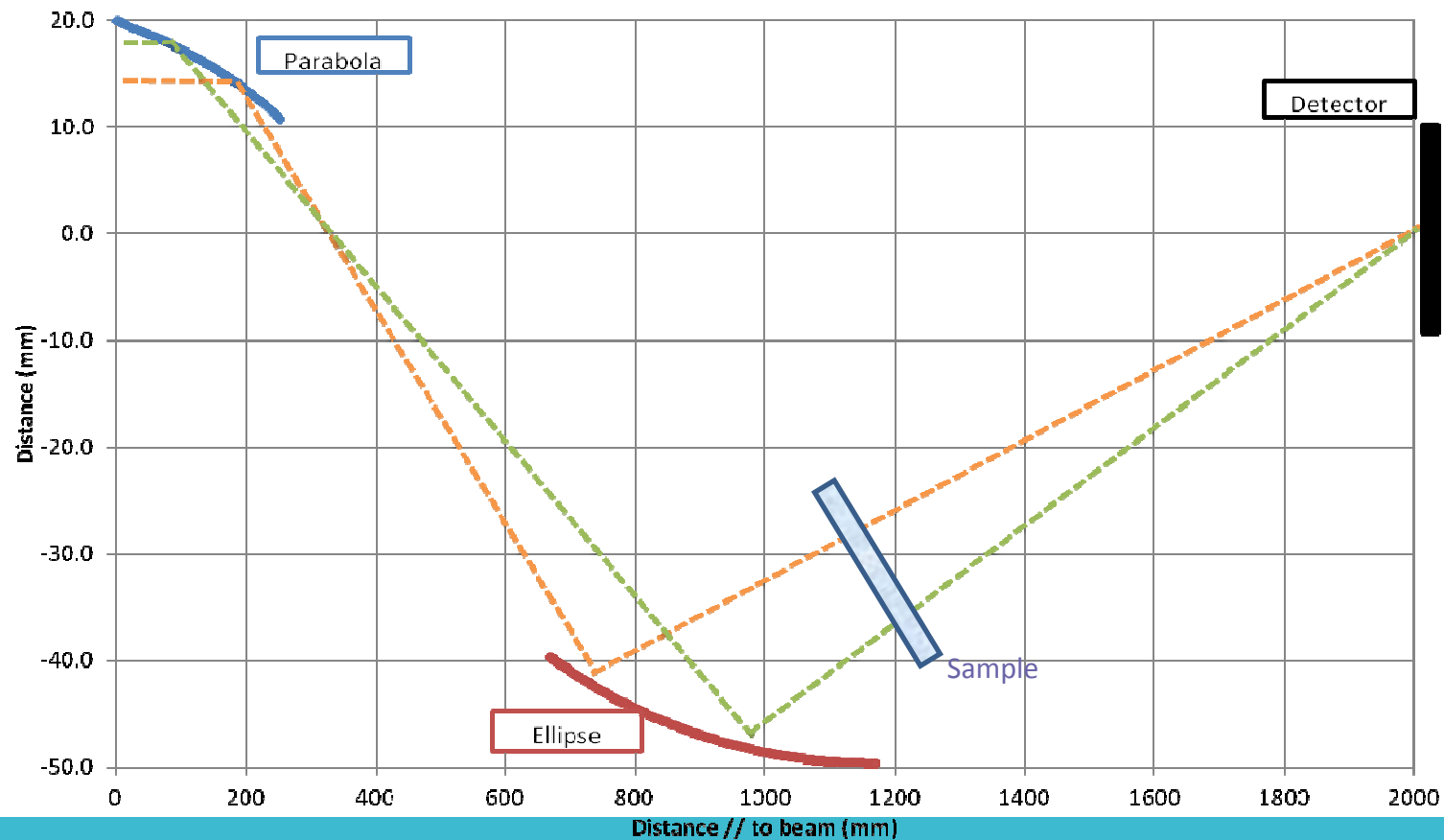
length 250 mm, height 30 mm, $m=3.4$

Elliptic mirror

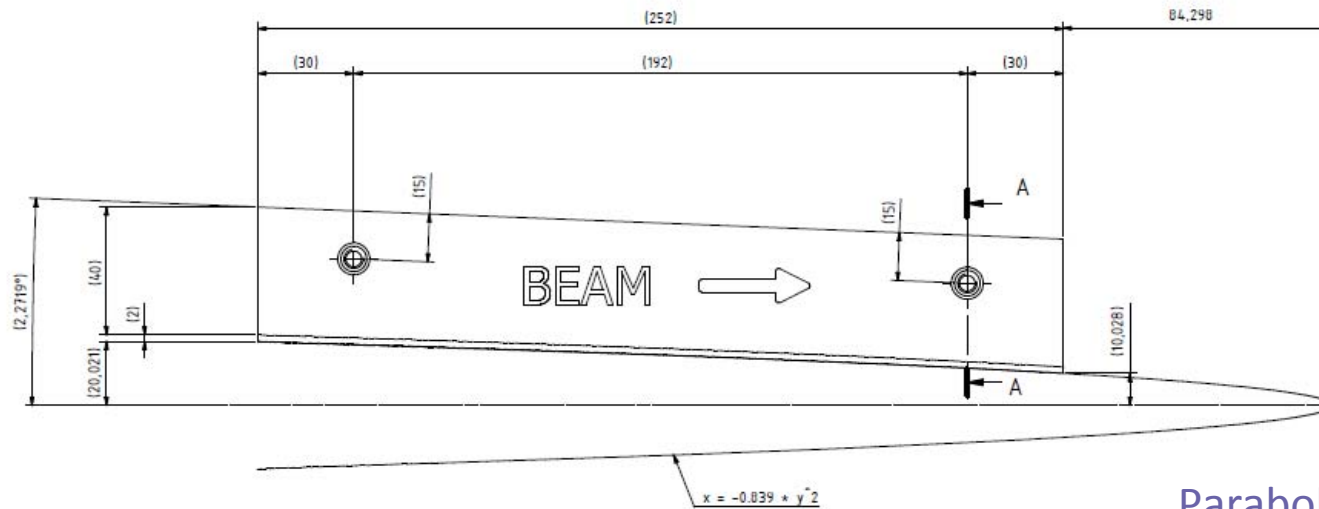
length 500 mm, height 30 mm, $m=3.4$

Sample to detector length

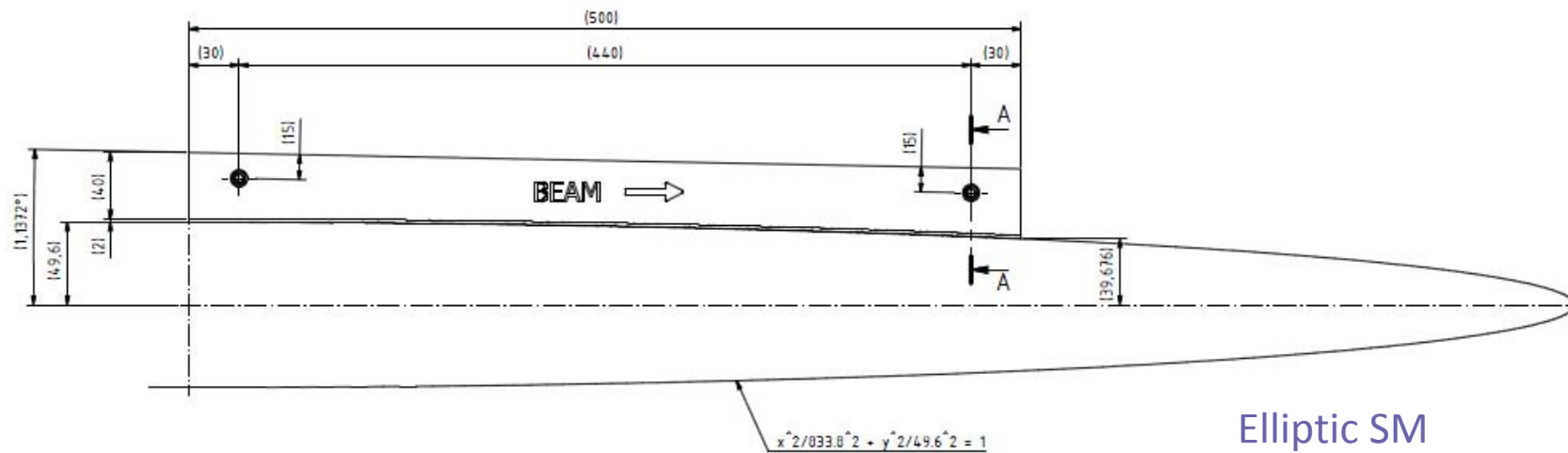
833 mm



Manufacture of the mirrors



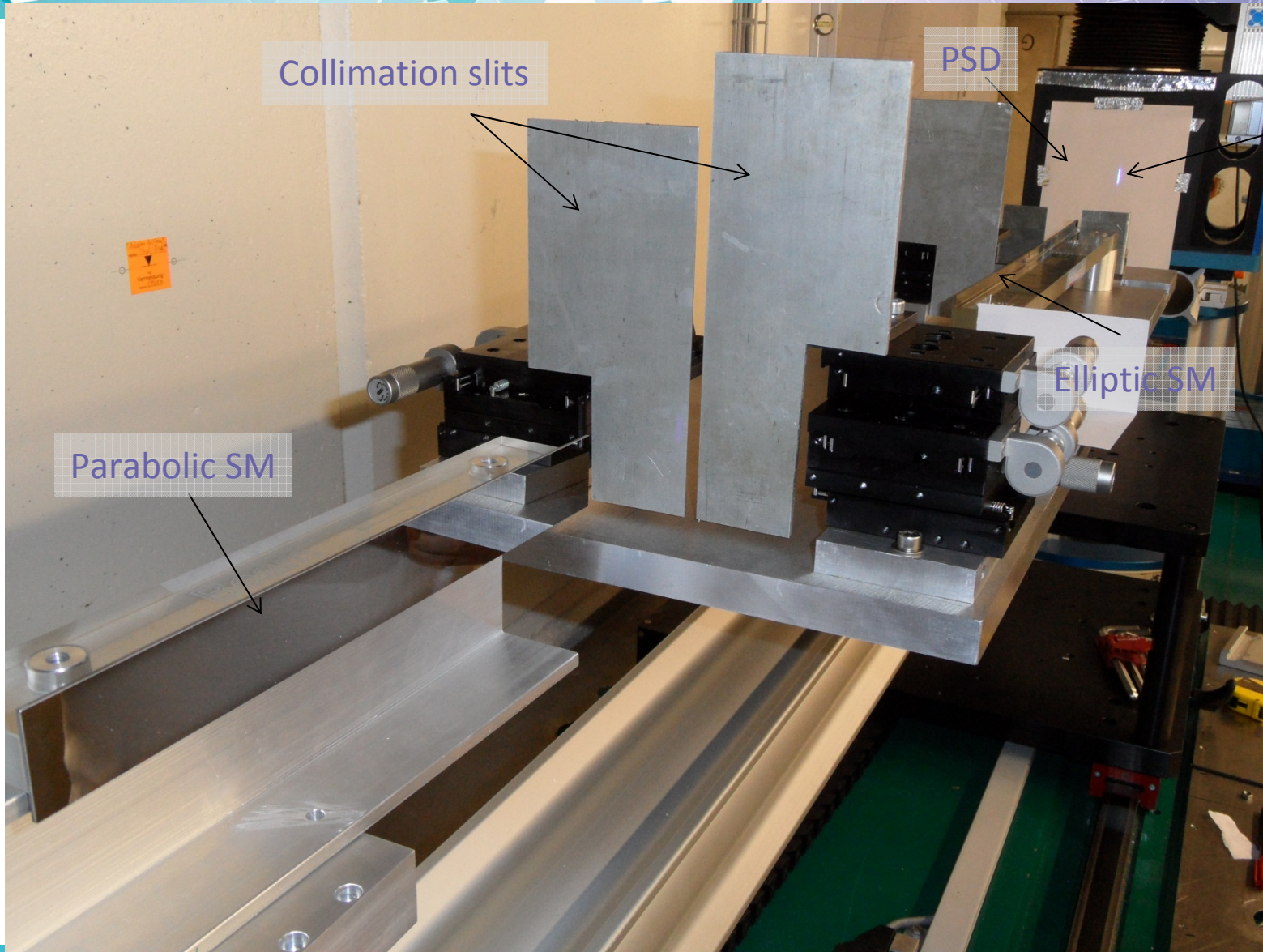
Parabolic SM



Elliptic SM



Test of prototype on BOA (T. Panzner) @ PSI, 03-06 Oct. 2011



Collimation slits

PSD

Laser spot after reflexion on both SM (for alignment purpose)

Elliptic SM

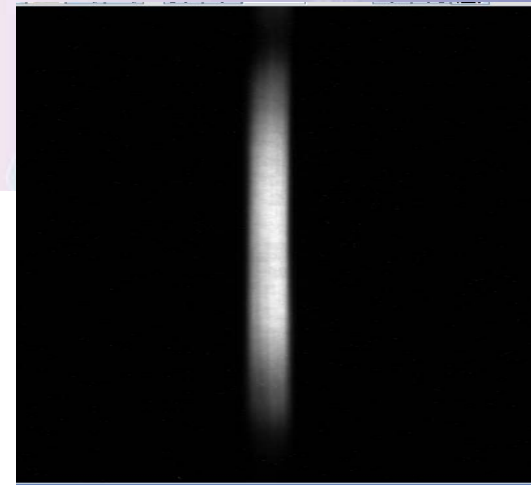
Parabolic SM



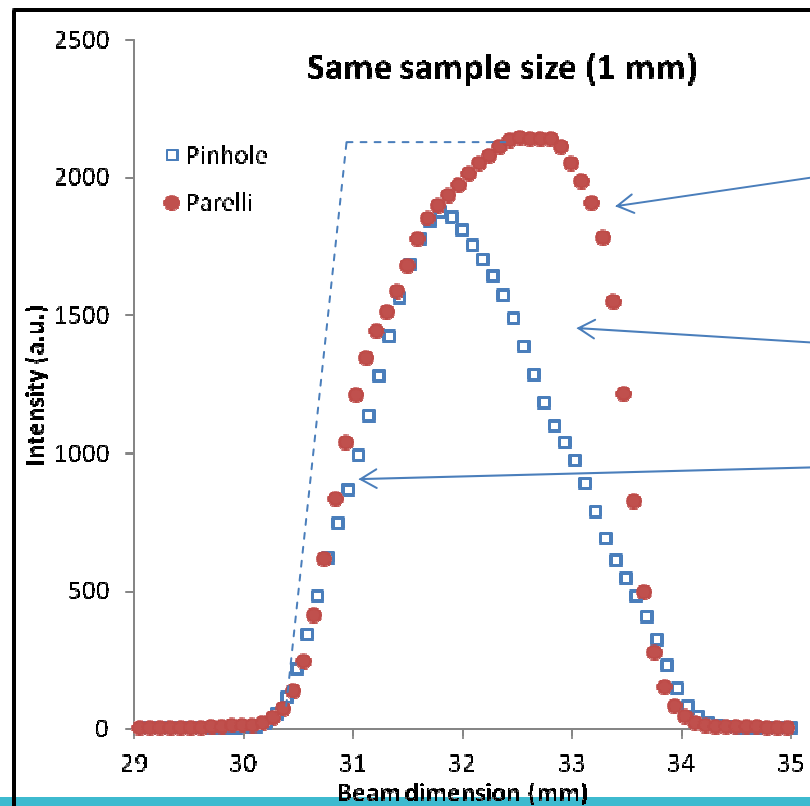
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Data treatment:
Integration along slit axis
Plot along perpendicular of slit axis

$\theta_{\min}=0.15^\circ$



Beam on the detector



Shape close to step distribution of intensity

Ratio of intensity is 1.25

No step distribution for geometrical constraints
(can be recovered by adding a SM)



Interests of the setup:

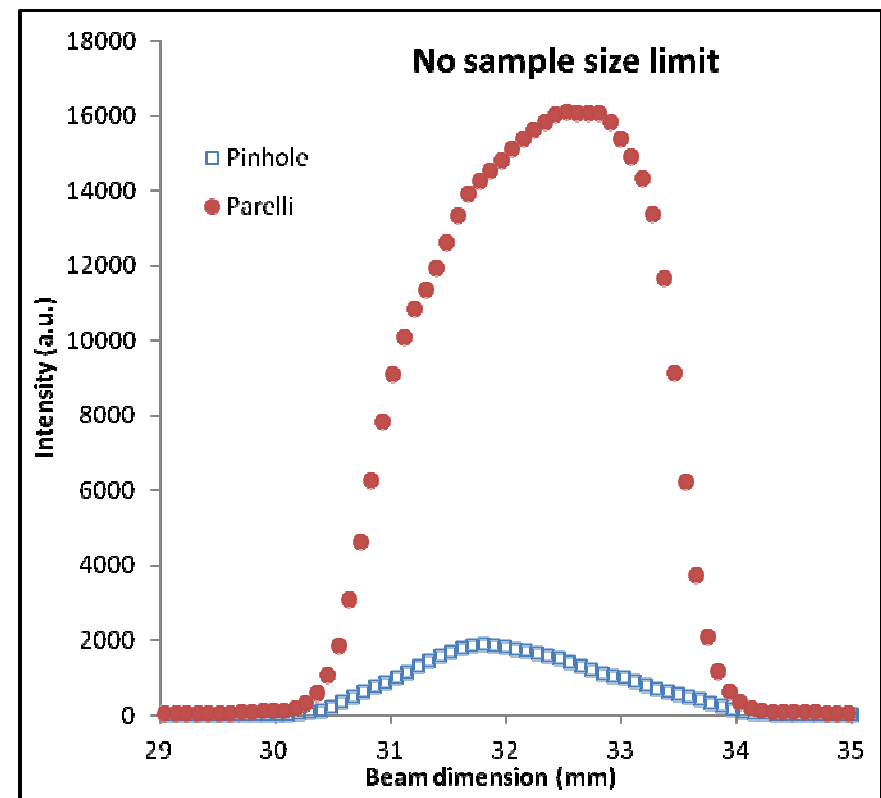
-Beam focusing without aberration

-Gain approx. 3 compared to pinhole with same sample size

- The beam size on the detector is independent of the sample size

→ Large samples can be used for large intensity gain

Gain 10 along one axis
→ 100 with a 3D setup.





Next steps

- Finish the data treatment and compare with simulations
- Design a 3D prototype

Aknowledgements to:

- Patrice Permingeat (LLB)
- Jochen Stahn (PSI)
- Tobias Panzner (PSI)